Electronic Acknowledgement Receipt					
EFS ID:	6150890				
Application Number:	10787120				
International Application Number:					
Confirmation Number:	4693				
Title of Invention:	LASER IRRADIATION METHOD, LASER IRRADIATION APPARATUS, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE				
First Named Inventor/Applicant Name:	Koichiro Tanaka				
Customer Number:	31780				
Filer:	Eric J. Robinson/Tiffany Banks				
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Application Type:	Utility under 35 USC 111(a)				

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Applicant Arguments/Remarks Made in	Response.pdf	1072173	no	6
' an Amendment	· · ·	03c778aab5ff3adf5665127c16a9bdfc6a337 8bd			

Warnings:

Information:

2		IDS_09_25_2009.pdf	450429	yes	3
2			26634b47d5c59b9911369bb049cb462864 851a07		3
	Multip	oart Description/PDF files in	n.zip description		
	Document Description		Start	End	
	Transmittal Letter		1	2	
	Information Disclosure Statement (IDS) Filed (SB/08)		3	3	
Warnings:					
Information:					
3	Foreign Reference	JP53029323.pdf	387958	no	4
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Warnings:					
Information:					
4	Foreign Reference	JP2002289524.pdf	5321391	no	28
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Information:					
5	Foreign Reference	JP2001189458.pdf	3509326 240a4d39dec630235219e8c9e446c050619	no	19
Warnings:			9857d		
Information:					
			1203216	no	7
6	Foreign Reference	JP2003347237.pdf	b668141efc75f554f906a54467b0d3d820c8 86d3		
Warnings:					
Information:					
7	Foreign Reference	JP57104217.pdf	547756	no	4
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Warnings:					
Information:					
8	8 Foreign Reference	JP11307450.pdf	4417368	no	30
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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

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